

APPLICATION DATA SHEET

APPLICATION INFORMATION

Application Type:: REGULAR
Subject Matter:: UTILITY
Suggested Group Art Unit:: 1765
CD-ROM or CD-R?:: NONE
Title:: METHOD AND COMPOSITION FOR
SELECTIVELY ETCHING AGAINST
COBALT SILICIDE
Attorney Docket Number:: 150.00560104
Total Drawing Sheets:: 6

INVENTOR INFORMATION

Applicant Authority Type:: INVENTOR
Primary Citizenship Country:: United States of America
Status:: FULL CAPACITY
Given Name:: Whonchee
Family Name:: Lee
City of Residence:: Boise
State or Province of Residence:: Idaho
Country of Residence:: United States of America
Street of Mailing Address:: 493 South Browning Avenue
City of Mailing Address:: Boise
State or Province of Mailing Address:: Idaho
Country of Mailing Address:: United States of America
Postal or Zip Code of Mailing Address:: 83709

Applicant Authority Type:: INVENTOR
Primary Citizenship Country:: Peoples Republic of China
Status:: FULL CAPACITY
Given Name:: Yongjun
Middle Name:: Jeff
Family Name:: Hu
City of Residence:: Boise
State or Province of Residence:: Idaho
Country of Residence:: United States of America
Street of Mailing Address:: 2571 South Culpeper Avenue
City of Mailing Address:: Boise

[illegible]

Application::	Continuity Type::	Parent Application::	Parent Filing Date::
This Application	Continuation of	09/560,268	04/20/00
09/560,268	Division of	08/914,935	08/20/97

- Assignee Name:: Micron Technology, Inc.
- Street of Mailing Address:: 8000 South Federal Way
- City of Mailing Address:: Boise
- State or Province of Mailing Address:: Idaho
- Country of Mailing Address:: United States of America
- Postal or Zip Code of Mailing Address:: 83707